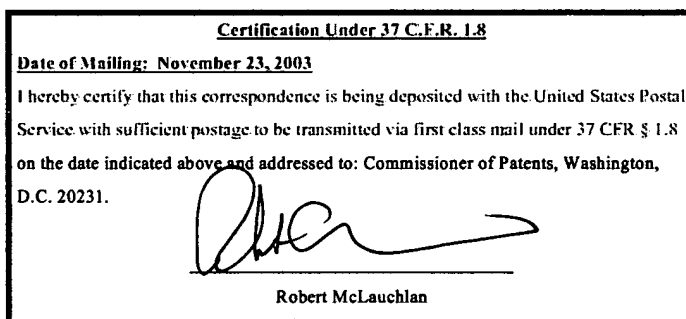


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Brian T. Rosenberger, et al.
Serial No. 10/010,506
Filing Date: November 13, 2001
Group Art Unit: 2872
Examiner: Amari, Alessandro V.
Title: SYSTEM AND METHOD FOR THE HOLOGRAPHIC DEPOSITION
OF MATERIAL

Commissioner of Patents
Washington, D.C. 20231



Dear Sir:

AMENDMENT

Please amend the Application as follows:

IN THE SPECIFICATION

Please add the following new paragraph as the first paragraph on page 1:

-- CROSS-REFERENCE TO RELATED APPLICATION

This application claims the benefit of priority to U.S. Provisional Patent Application No. 60/249,678 entitled "System and Method for Holographic Deposition of Material", filed on November 17, 2000, and is incorporated herein by reference in its entirety. --

Please delete the first paragraph after the section title, BACKGROUND OF THE INVENTION on page 1, as follows:

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